

Electronic Filing System (EFS) Data
Electronic Patent Application Submission
USPTO Use Only

EFS ID: 65592
Application ID: 10710737 
Title of Invention: CHEMICAL TREATMENT TO
RETARD DIFFUSION IN A
SEMICONDUCTOR OVERLAYER
First Named Inventor: Kevin Chan
Domestic/Foreign Application: Domestic Application
Filing Date: 2004-07-30
Effective Receipt Date: 2004-07-30
Submission Type: Utility Patent Filing
Filing Type: new-utility
Confirmation number: 4736
Attorney Docket Number: FIS920040027

Total Fees Authorized: 954.0
Payment Category: Deposit Account
Deposit Account Number: 90458
Deposit Account Name: Todd M. C. Li
RAM Payment Status: RAM has not been processed

Digital Certificate Holder: cn=Todd M. C. Li,ou=Registered Attorneys,ou=Patent and Trademark
Office,ou=Department of Commerce,o=U.S. Government,c=US
Certificate Message Digest: 6172c25ee6a264846c75d31d46c2e236cc149123

PATENT APPLICATION SERIAL NO. _____

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE
FEE RECORD SHEET

07/30/2004 HTECKLU1 00000037 090458 10710737

01 FC:1001	770.00 DA
02 FC:1202	144.00 DA

PTO-1556
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